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Bib Data Sheet

SERIAL NUMBER 10/706,902	FILING DATE 11/12/2003 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. AMAT/8501/ETCH/DRIE/JB
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APPLICANTS

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** CONTINUING DATA *****

This appln claims benefit of 60/493,824 08/08/2003

Bt

** FOREIGN APPLICATIONS *****

None Bt

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 02/06/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	DRAWING 6	CLAIMS 40	CLAIMS 3	
Verified and Acknowledged Examiner's Signature	<i>Binkman</i>	Initials			

ADDRESS

55649
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TITLE

Selective etch process of a sacrificial light absorbing material (SLAM) over a dielectric material

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)

FILING FEE FEES: Authority has been given in Paper